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Bib Data Sheet

SERIAL NUMBER 10/550,853	FILING OR 371(c) DATE 09/22/2005 RULE	CLASS 438	GROUP ART UNIT 2823	ATTORNEY DOCKET NO. NL03 0357 US1
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## APPLICANTS

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yes K.N.

## \*\* CONTINUING DATA \*\*\*\*\*

This application is a 371 of PCT/IB04/50333 03/25/2004

yes K.N.

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

EUROPEAN PATENT OFFICE (EPO) 03100821.2 03/28/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 06/04/2006

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY NETHERLANDS	SHEETS DRAWING 6	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 1
35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance				
Verified and Acknowledged K. Meunier Examiner's Signature	K.N. Initials			

## ADDRESS

24738

## TITLE

Method of epitaxial deposition of an n-doped silicon layer

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